

O I P E Honeywell's Docket No. H0003967 US -4780
Proprietor's Docket No. 7036932002-3221000

PATENT

JUL 29 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

The application of: **LI et al.**Group No.: **Not Yet Assigned**Application No.: **10/532,939**Examiner: **Not Yet Assigned**Filed: **April 28, 2005**For: **Gas Layer Formation Materials**

Mail Stop DD
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

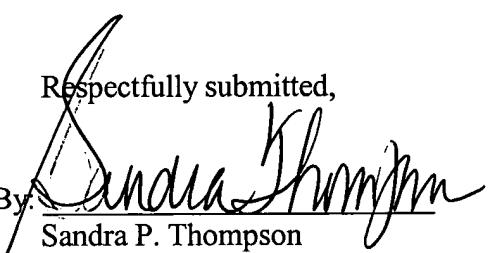
**TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT
WITHIN THREE MONTHS OF FILING OR
BEFORE MAILING OF FIRST OFFICE ACTION (37 C.F.R. 1.97(b))**

**IDENTIFICATION OF TIME OF FILING THE ACCOMPANYING
INFORMATION DISCLOSURE STATEMENT**

The information disclosure statement submitted herewith is being filed within three months of the filing date of the application or date of entry into the national stage of an international application or before the mailing date of a first Office action on the merits, whichever event occurs last. 37 C.F.R. 1.97(b).

Date: July 26, 2005

Respectfully submitted,

By: 
Sandra P. Thompson
Reg. No. 46264

Attorneys for Applicant
Bingham McCutchen
600 Anton Blvd., 18th Floor
Costa Mesa, CA 92835
Tel: (714) 830-0600
Fax: (714) 830-0700

CERTIFICATE OF MAILING (37 C.F.R. 1.8(a))

I hereby certify that, on the date shown below, this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail, in an envelope addressed to the Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450.


Kristin J. Azcona

Date: July 26, 2005

Honeywell's Docket No. H0003967 US -4780
Practitioner's Docket No. 7036932002-3221000

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **Li et al.**

Serial No: **10/532,939**

Filed: **April 28, 2005**

For: **GAS LAYER FORMATION
MATERIALS**

Group: **Not Yet Assigned**

Examiner: **Not Yet Assigned**

INFORMATION DISCLOSURE STATEMENT

**MAIL STOP DD
COMMISSIONER OF PATENTS
PO Box 1450
ALEXANDRIA, VA 22313-1450**

Sir:

In accordance with the duty of disclosure imposed by 37 C.F.R. § 1.56 to inform the United States Patent and Trademark Office of all references coming to the attention of the Applicant(s) or attorneys or agents for Applicant(s) which are or may be material to the examination of the subject application, attorneys for the Applicant(s) hereby invite the Examiner's attention to the references listed in the accompanying PTO Form 1449 entitled "List of References Cited".

This submission is understood to complement the results of the Examiner's own independent search. The submission of this Disclosure Statement should not be construed as a representation that a search was made, or that the cited items are inclusive of all relevant and material citations that may be available publicly.

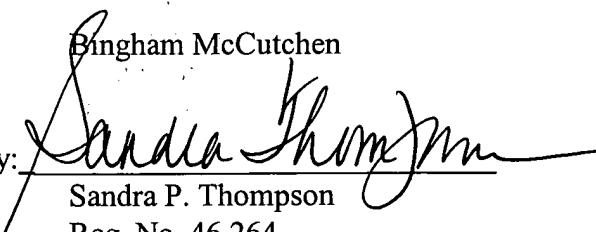
Honeywell's Docket No. H0003967 US -4780
Practitioner's Docket No. 7036932002-3221000

Applicant(s) respectfully request that the Examiner review the foregoing references, as set forth in the Form PTO-1449, and that they be made of record in the file history of the above-captioned application.

Respectfully submitted,

Bingham McCutchen

Dated: July 26, 2005

By: 

Sandra P. Thompson

Reg. No. 46,264

Attorneys for Applicant(s)
600 Anton Blvd., 18th Floor
Costa Mesa, CA 92626
Tel: 714-830-0622
Fax: 714-830-0722

LIST OF REFERENCES CITED BY APPLICANT <i>(Use several sheets if necessary)</i>	ATTY. DOCKET NO.	SERIAL NO.
	7036932002-3221000	10/532939
	APPLICANT	
	Li et al.	
FILING DATE	GROUP	
April 28, 2005	Not Yet Assigned	

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		US 2002/0028575	03/07/02	Besling et al.	438	638	08/30/01
		6,093,636	07/25/00	Carter et al.	438	623	07/08/98
		US 2003/0151031	08/14/03	Li et al.	252	570	05/29/02
		US 2002/0052125	05/02/02	Shaffer, II et al.	438	780	08/20/01

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	A	WO 00/51177	08/31/00					
	B							

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

	C	PCT International Search Report dated May 10, 2004.
	D	PCT Written Opinion dated November 3, 2004.
	PP	

EXAMINER	DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Please acknowledge receipt of the following by affixing hereon the Official date stamp and returning this card to our office.

Information Disclosure Statement
Gas Layer Formation Materials

Title: Gas Layer Formation Materials
Inventor: Bo Li, et al.
Filing Date: April 28, 2005
Serial Number: 10/532939
Matter Type: Patent - US
Date of Deposit: April 28, 2005
Matter #: 7036932002-3221000
Enclosures:

(1) IDS Transmittal (1 page); (2) Information Disclosure Statement (2 pages); (3) Form 1449 w/copies of References cited; and (4) postcard.

DATE MAILED: 7/26/05 SBU: 4180
PATENT APPLICATION FOR: Gas Layer Formation Materials

INVENTOR(S): W. et al.

SERIAL NO.: 10/532939

**THE FOLLOWING HAS BEEN RECEIVED IN THE U.S. PATENT AND TRADEMARK OFFICE
ON THE DATE STAMPED HEREON:**

- Assignment and Cover Sheet: \$ 10 Information Disclosure Statement ISR From PTO 1449 with 7 References \$ 10
- Request for Corrected Filing Receipt
- Amendment/Response (1 page(s)) \$ 10
- Petition for Extension of Time (1 months) \$ 10
- Amendment After Final Rejection (1 page(s)) \$ 10
- Notice of Appeal
- Appeal Brief (1 page(s)) \$ 10
- Issue Fee Transmittal \$ 10
- Formal Drawing(s); No. of Sheets 1
- Total fees charged to Deposit Account No. 01-1125: \$ 10

OTHER None Attorney: S. J. Johnson
Attorney Docket No.: 100000105 \$ 10